



00984.002535.3

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Yuichi YAMADA et al.) : Examiner: Q. L. Tan
Application No.: 10/024,139) : Group Art Unit: 2878
Filed: December 21, 2001) : Allowed: May 20, 2003
For: SCANNING EXPOSURE APPARATUS AND) : Confirmation No.: 4039
DEVICE MANUFACTURING METHOD : August 20, 2003
(As Amended))

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to further examination on the merits, please amend the above-identified application
as follows: